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Integrated chip package structure using silicon substrate and method of manufacturing the same

Appl. No.

: 10/755,042

Confirmation No. 8665

Applicant

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Jin-Yuan Lee,

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: Fenty, Jesse A

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Commissioner for Patents

P.O. Box 1450

Alexandria VA 22313-1450

AMENDMENT

5 Sir:

In response to the Final Office action mailed Jan. 4, 2007, please consider the remarks as follows:

Remarks/Arguments begin on page 2 of this paper.